



Docket No.: 264681US0X PCT

OBLON
SPIVAK

ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/524,037

Applicants: Kai SCHUMACHER, et al.

Filing Date: February 9, 2005

For: SILICON DIOXIDE DISPERSION

Group Art Unit: 1791

Examiner: Dehghan

SIR:

Attached hereto for filing are the following papers:

Restriction Response/ Copy of IPER/ Request for Extension of Time - 1 month

Our online credit card payment in the amount of **\$120.00** is being made covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Stephen G. Baxter
Registration No. 32,884

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)